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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
SAKAI et al

Serial No. 10/805,296

Filed: March 22, 2004



Atty. Ref.: 2635-206 (LSN)

TC/A.U.: 2856

Examiner: Not Yet Assigned

For: GAS CONCENTRATION DETECTING APPARATUS

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October 3, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Attention is directed to the attached Japanese Office Action in a counterpart of this application and to a copy of each non-U.S. patent document newly cited therein. A Form PTO/SB/08a is also attached.

Official consideration and citation of all identified documents is requested.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION	ATTY. DOCKET NO.	SERIAL NO.
OCT 03 2006	2635-206	10/805,296
PATENT & TRADEMARK OFFICE	APPLICANT	
	SAKAI et al	
(Use several sheets if necessary)	FILING DATE	TC/A.U.
	March 22, 2004	2856

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS							TRANSLATION	
DOCUMENT		DATE	COUNTRY	CLASS	SUBCLASS	YES	NO	
	6-3318	1/1994	Japan			ABSTRACT		
	11-64276	3/1999	Japan (corresp. to USPN 6,082,176)			U.S.		
	2000-180409	6/2000	Japan			ABSTRACT		
	2002-71640	3/2002	Japan (corresp. to USPN 6,547,955 and 6,849,174)			U.S.		
	2003-50226	2/2003	Japan (corresp. to USPN 6,870,142)			U.S.		

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

*Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.